

**Appendix A**  
(deletions are bracketed and insertions are underlined)

**IN THE CLAIMS:**

1    3.     (Amended) A probe card as claimed in claim 1 [**or claim 2**], wherein said contactor is  
2     extended to a predetermined direction from a surface of said substrate.

1    4.     (Amended) A probe card as claimed in [**any one of**] claim[s] 1 [**to 3**], wherein said  
2     contactor has a vertical elasticity against a surface of said substrate.

1    5.     (Amended) A probe card as claimed in [**any one of**] claim[s] 1 [**to 4**], wherein at least  
2     a portion of said signal transmission path near said end of it is made of the same amorphous  
3     material used for said contactor.

1    6.     (Amended) A probe card as claimed in [**any one of**] claim[s] 1 [**to 5**] further  
2     comprising a grounding line, which is grounded, formed to be apart from and in parallel to  
3     said signal transmission path.

1    7.     (Amended) A probe card as claimed in [**any one of**] claim[s] 1 [**to 6**] further  
2     comprising a low-resistance unit having lower resistance than that of said signal transmission  
3     path, said low-resistance unit being formed near said signal transmission path.

1    8.     (Amended) A probe card as claimed in [**any one of**] claim[s] 1 [**to 7**], wherein said  
2     contactor comprises a contacting point made of a contact-point material on an end of it.

1    9.     (Amended) A probe as claimed in [**any one of**] claim[s] 1 [**to 8**], wherein said  
2     contactor is coated with a metal material.

1 10. (Amended) A probe card as claimed in [any one of] claim[s] 1 [to 9] further  
2 comprising a voltage providing unit for providing a predetermined voltage, said voltage  
3 providing unit being provided on a backside of said one side of said substrate.

1 13 (Amended) A probe card as claimed in [any one of] claim[s] 1 [to 12] further  
2 comprising a plurality of contactors made of an amorphous material having a supercooled  
3 liquid phase region, wherein said plurality of contactors are electrically coupled to said  
4 contactors formed on said one side of said substrate through said signal transmission paths  
5 and formed on [said] a backside of said substrate.

1 16. (Amended) A method for forming a contactor as claimed in claim 14 [or 15], wherein  
2 said amorphous material layer is formed by sputtering said amorphous material.

1 17. (Amended) A method for forming a contactor as claimed in [any one of] claim[s] 14  
2 [to 16], wherein said step for forming said contactor comprises a step for causing a plastic  
3 deformation of said free unit toward a predetermined direction from said substrate.

1 18. (Amended) A method for forming a contactor as claimed in [any one of] claim[s] 14  
2 [to 17], wherein said step for forming said contactor comprises a step for heating said free  
3 unit.

1 19. (Amended) A method for forming a contactor as claimed in [any one of ] claim[s] 14  
2 [to 18], wherein said step for forming said contactor comprises a step for providing a bending  
3 adjustor at a predetermined position toward a direction of gravity from [said] a surface of said  
4 substrate.

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1 21. (Amended) A method for forming a contactor as claimed in [any one of] claim[s] 14  
2 [to 18], wherein said step for forming said contactor comprises a step for providing a bending  
3 adjusting member comprising an engaging unit for suppressing movement of said substrate in  
4 a direction of gravity and a bending adjustor for determining said predetermined position  
5 toward a direction of gravity from [said] a surface of said substrate.